



Docket No.: 0756-7204

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)

Koichiro TANAKA)

Serial No. 10/671,539)

Group Art Unit: 2828

Filed: September 29, 2003)

Examiner: Minsun Harvey

For: LASER IRRADIATION APPARATUS AND)

METHOD OF MANUFACTURING)

SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
P. O. Box 1450, Alexandria VA 22313-1450, on 7-11

[Signature]

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

[Signature]

Eric J. Robinson
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789
(571) 434-9499 (Fax)